

Electronic Patent Application Fee Transmittal

Application Number:	10571267			
Filing Date:	12-Feb-2007			
Title of Invention:	Lithography Lens System And Projection Exposure System Provided With At Least One Lithography Lens System Of This Type			
First Named Inventor/Applicant Name:	Hans-Juergen Rostalski			
Filer:	Suzanne Christine Walts/Casey Richardson			
Attorney Docket Number:	Q93721			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Claims in excess of 20	1615	3	52	156
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 1 month with \$0 paid	1251	1	130	130
Miscellaneous:				
Total in USD (\$)				286